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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): UENO et.al.	Atty. Dkt.: 01-559
Serial No.: 10/779,658	Group Art Unit: 2814
Filed: February 18, 2004	Examiner:
Title: SEMICONDUCTOR PRESSURE SENSOR DEVICE	

Commissioner for Patents
Alexandria, VA 22314

Date: January 19, 2006

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT


Sir:

Pursuant to 37 C.F.R. §1.56, the reference(s) listed on the attached Form PTO-1449 is/are being brought to the attention of the Examiner without any admission that it/they constitute(s) statutory prior art, or without any admission that it/they contain(s) subject matter that anticipates the invention or renders the invention obvious to a person of ordinary skill in the art.

Further, pursuant to 37 C.F.R. §1.97(e), the undersigned hereby certifies that each of the listed reference(s) was first cited in a Communication (copy enclosed) from a foreign patent office in connection with a counterpart foreign application not more than three months prior to the filing of this statement. Please note that the reference JP-A-2001-153746 (English counterpart US 6,512,255) cited in the Communication was already cited in the information disclosure statement filed with the present application on February 18, 2004.

Although no fees are believed to be due at this time, it is respectfully requested that any such fees be charged to Deposit Account 50-1147. Also, the Examiner is requested to initial the attached PTO Form-1449 and to return a copy of same to the undersigned attorney as proof that the listed reference(s) has/have been considered and made of record.

Respectfully submitted,


James E. Barlow
Reg. No. 32,377

Posz Law Group, PLC
12040 South Lakes Drive, Suite 101
Reston, VA 20191
(703) 707-9110 (phone)
Customer No. 23400

FORM PTO-1449	ATTY. DKT NO.	01-559	SER. NO.	10/779,658
	APPLICANT	UENO et al.		
	FILING DATE	February 18, 2004	GROUP	2814

REFERENCE DESIGNATION

U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS
	US 6,103,025	8/15/2000	HERKLOTZ et al.		

FOREIGN PATENT DOCUMENTS

TRANSLATION

		DOCUMENT NUMBER	DATE	COUNTRY	NAME	CLASS	SUB CLASS	YES	NO	
									Eng. Abstract	
		EP 0 761 831A1	3/12/97	EUROPE				X		
		JP-A-H06-112256	4/22/94	JAPAN						X
		EP 0 822 264 A1	2/4/98	EUROPE				X		

* Full English text is available in machine-translated form in JPO (Japanese Patent Office) English language web site at <http://www1.ipdl.jpo.go.jp/PA1/cgi-bin/PA1INDEX>.

OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, etc.)

		Office Action issued from French Patent Office issued on December 23, 2005 for the corresponding French patent application No. FR 0401904 (a copy thereof)
EXAMINER		DATE CONSIDERED